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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 7747
Mamoru NAKASUJI et al. : Docket No. 2003-1217A
Serial No. 10/651,105 : Group Art Unit 2881
Filed August 29, 2003 : Examiner James P. Leybourne
ELECTRON BEAM SYSTEM :

RESPONSE TO RESTRICTION REQUIREMENT

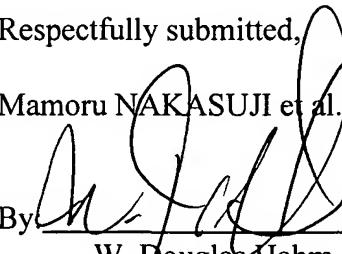
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Sir:

In response to the Restriction Requirement of November 2, 2004, Applicants hereby elect the invention of Group I, claims 1-26 and 54-62, drawn to a projection type transmission microscope, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,
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